

Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 118490		APPLICATION NO. 10/786,151	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANT Mitsutoshi MIYASAKA  FILING DATE February 26, 2004			
U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Name			
PB	1	5,824,574	10/20/1998	Yamazaki et al.			
FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation	
PB	2	JP-A-08-321466	12/03/1996	Japan	X	X	
PB	3	JP-A-01-264215	10/20/1989	Japan	X		
OTHER DOCUMENTS							
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)					
PB	4	Van der Wilt, Paul, van Dijk, B.D., Bertens, G.J., Ishihara, R., and Beenakker, C.I.M., <i>Formation of Location-Controlled</i>					
		<i>Crystalline Islands Using Substrate-Embedded Seeds in Excimer-Laser Crystallization Silicon Films</i> , 9/17/2001, Vol. 79,					
		No. 12, Pages 1819-1821.					
EXAMINER		Paul B. Dahl			DATE CONSIDERED		
					8/6/2007		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: July 12, 2007